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PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

Tadahiro ASAISHI

Application No.: 10/724,737

Filed: December 2, 2003

For: EXPOSURE APPARATUS

U.S. Patent No. 6,882,407 B2

Issued: April 19, 2005

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) Examiner: H. Nguyen
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) Group Art Unit: 2851
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) August 24, 2005
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)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Certificate of Correction Branch

Certificate
AUG 29 2005
of Correction

REQUEST FOR
CERTIFICATE OF CORRECTION
UNDER RULES 322 AND 323

Sir:

Patentee requests that a Certificate of Correction be issued by the Patent and Trademark Office due to errors which appear in the printed patent as a result of U.S. Patent and Trademark Office mistakes and mistakes of a minor nature which are not the fault of the Patent and Trademark Office.

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Accompanying this letter is a check for \$100.00 to cover the statutory fee for such Certificate of Correction. Any additional fee required by this paper may be charged to Deposit Account No. 06-1205.

Patentee's undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", written over a horizontal line.

Attorney for Patentee
Steven E. Warner
Registration No. 33,326

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UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,882,407 B2

DATED : April 19, 2005

INVENTOR(S): Tadahiro ASAISHI

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

COLUMN 1:

Lines 5-9 should be deleted and the following inserted therefor:

-- The present invention relates to an exposure apparatus suitable for manufacturing a device typified by, e.g., a semiconductor device or liquid crystal display device. --

Line 13, "apparatus" should read -- apparatus, --.

COLUMN 7:

Line 20, "conformity" should read -- uniformity --.

Line 27, "hundres" should read -- hundreds --.

Line 59, "integarated" should read -- integrated --.

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FORM PTO 1050 (REV. 3.82)

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